

PATENT NUMBER and
ISSUE DATE

U.S. UTILITY Patent Application

APPL NUM	FILING DATE	CLASS	SUBCLASS	GAU	EXAMINER
10047119	01/17/2002	250		2878	

**APPLICANTS: Hong Minghui; Ye Kaidong; An Chengwu; Liu Da Ming;

**CONTINUING DATA VERIFIED:

** FOREIGN APPLICATIONS VERIFIED:

SINGAPORE 200104057-5 07/06/2001

PG-PUB	DO NOT PUBLISH <input type="checkbox"/>	RESCIND <input type="checkbox"/>	
Foreign priority claimed		<input type="checkbox"/> yes <input type="checkbox"/> no	ATTORNEY DOCKET NO
35 USC 119 conditions met		<input type="checkbox"/> yes <input type="checkbox"/> no	2826-9
Verified and Acknowledged Examiners's initials			
TITLE : Method and apparatus for cutting a multi-layer substrate by dual laser irradiation			
U.S.DEP.T. OF COMM./PAT.& TM-PTO-436L(Rev. 12-94)			

NOTICE OF ALLOWANCE MAILED		Assistant Examiner	CLAIMS ALLOWED	
			Total Claims	Print Claim for O.G
ISSUE FEE		DRAWING		
Amount Due	Date Paid	Sheets Drwg.	Figs.Drwg.	Print Fig.
<input type="checkbox"/> TERMINAL		Primary Examiner		
DISCLAIMER		Application Examiner		
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